



P/4178-9

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Confirmation No.: 4349

Masanobu SATO et al.

Date: May 3, 2006

Serial No.: 10/669,520

Group Art Unit: 1734

Filed: September 24, 2003

Examiner: Yewebdar T. Tadesse

For: SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING SYSTEM

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of two Office Actions issued by a patent searching authority other than the PTO and the cited art together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in communications from a foreign patent office in a counterpart foreign application and that this communication was not received by any individual designated in 37 C.F.R. 1.56(c) more than 30 days prior to the filing of this Submission.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the Patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on May 3, 2006:

Respectfully submitted,

James A. Finder

Name of applicant, assignee or
Registered Representative

Signature
May 3, 2006

Date of Signature

James A. Finder
Registration No.: 30,173
OSTROLENK, FABER, GERB & SOFFEN, LLP
1180 Avenue of the Americas
New York, New York 10036-8403
Telephone: (212) 382-0700

JAF:lf
Enclosures



APPLICANT'S ART CITATION

(Use several sheets if necessary)

Application 10/669,520

OFPS File No. P/4178-9

Applicant
Masanobu SATO et al.

Filing Date
September 24, 2003

Group Art Unit
1734

U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)

Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	10-116805	05-1998	Japan			X	
	2001-223195	08-2001	Japan			X	
	6-151398	05-1994	Japan			X	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Japanese Office Action issued April 17, 2006
	Japanese Office Action issued April 17, 2006

Examiner	Date Considered
----------	-----------------

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.